

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Jangjian, Shiu-Ko et al.

Docket No.

39524.8100

Serial No.

10/679,764

Filing Date

October 8, 2003

Examiner

To Be Assigned

Group Art Unit

1762

Invention: METHOD OF FORMING INTER-METAL DIELECTRIC LAYER STRUCTURE

JUN 03 2004

PATENT & TRADEMARK OFFICE

TO THE COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	24 -	20 =	4 x	\$18.00	\$72.00
INDEP. CLAIMS	3 -	3 =	0 x	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable) ☐					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$72.00

- ☐ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of _____
- ☒ A check in the amount of \$72.00 to cover the filing fee is enclosed.
- ☒ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-2814
- ☒ Any additional filing fees required under 37 C.F.R. 1.16.
- ☒ Any patent application processing fees under 37 CFR 1.17.

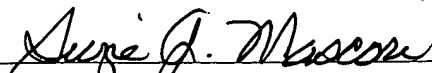


Signature

Dated: June 1, 2004

Cynthia L. Pillote, Reg. No. 42,999
Snell & Wilmer L.L.P.
One Arizona Center
400 East Van Buren
Phoenix, Arizona 85004-2202
(602) 382-6296
(602) 382-6070 - Facsimile
cpillote@swlaw.com

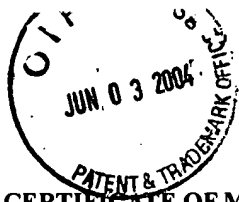
I certify that this document and fee is being deposited on June 1, 2004 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Signature of Person Mailing Correspondence

Suzie G. Mascari

Typed or Printed Name of Person Mailing Correspondence

CC:



IFW#

CERTIFICATE OF MAILING PURSUANT TO 37 C.F.R. §1.8

I hereby certify that this correspondence pursuant to 37 C.F.R. §1.8, is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Box Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on:

Date: June 1, 2004 By: Surge J. Mascari

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re application of:	JANGJIAN, Shiu-Ko, et al.	Docket No.:	39524.8100
Serial No.:	10/679,764	Group Art Unit:	1762
Filed:	October 8, 2003	Examiner:	To Be Assigned
Title:	METHOD OF FORMING INTER-METAL DIELECTRIC LAYER STRUCTURE	Confirmation No.:	8562

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

Prior to the initial examination of this non-provisional utility application, entitled "Method of Forming Inter-Metal Dielectric Layers Structure," by Shiu-Ko Jangjian et al., please amend the application as follows.

06/04/2004 5ZEWDIE1 00000016 10679764

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